LINEAR SENSOR ICS — FEATURES & BENEFITS

Linear sensor ICs are designed to respond to a wide range of positive or negative magnetic fields. Critical to the performance of linear ICs is their sensitivity and linearity over their specified operating temperature range. Allegro™ 4th-generation linear devices, the A3515 and A3516, optimize these design criteria. These ratiometric devices have a sensitivity of 5 mV/gauss and 2.5 mV/gauss, respectively, an operating temperature range of -40°C to +150°C, and are temperature compensated over their full operating range.

Linear Hall-effect devices are immune to most environmental disturbances that may affect optical or mechanical devices, such as vibration, moisture, dirt or oil films, ambient lighting, etc.

A Few of the Many Possible Applications

- Current sensing
- Power sensing (watt-hour metering)
- Current trip-point detection
- Strain gauge
- Biased (magnetically) sensing applications
- Ferrous metal detectors
- Proximity sensing
- Joy-stick with intermediate position sensing
- Liquid-level sensing
- Temperature/pressure/vacuum sensing (with bellows assembly)
- Throttle or air valve position sensing
- Non-contact potentiometers

Ratiometric Defined

Most linear Hall-effect devices are “ratiometric” where the quiescent output voltage (typically 1/2 the supply voltage) and sensitivity are proportional to the supply voltage.

For example: with a supply voltage of 5.0 V and no magnetic field present, the A3515 device’s quiescent output will typically be 2.5 V, and will change at a rate of 5.0 mV/G. If the supply voltage increases to 5.5 V, the quiescent output voltage will change to 2.75 V, and the sensitivity will increase to 5.5 mV/G.
### Allegro Type Number

<table>
<thead>
<tr>
<th>Characteristic</th>
<th>UGN3501*</th>
<th>UGN3503</th>
<th>UGN3508</th>
<th>UGN3507</th>
<th>UGN3506*</th>
<th>A3516</th>
<th>A3515</th>
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<tbody>
<tr>
<td>Ratiometric</td>
<td>no</td>
<td>yes</td>
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<td>4.5—6 V</td>
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<td>3.6 V</td>
<td>VCC/2</td>
<td>VCC/2</td>
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<td>±50 G</td>
<td>±35 G</td>
<td>±20 G</td>
<td>±10 G</td>
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</table>

*Discontinued — shown for comparison only.

### A3506/07/08 Family of Linear Devices

The original (1978) UGN3501/03 linear Hall-effect devices met the basic requirement for contactless sensing but were extremely sensitive to temperature changes and mechanical stress. The A3506/07/08 are 2nd-generation linear devices utilizing multiple devices to cancel out these effects on the Hall device.

The output of these linear devices is set to compensate for the negative temperature coefficient of samarium-cobalt magnets (-0.02%/°C).

### A3515/16 Family of Linear Devices

The A3515/16 BiCMOS linear devices utilize a single Hall device that is electronically rotated to cancel out the stress effects on the Hall device. These devices use a proprietary dynamic offset cancellation technique, with an internal high-frequency clock to reduce the residual offset voltage of the Hall element, which is normally caused by device overmolding, temperature dependencies, and thermal stress. This technique produces devices that have an extremely stable quiescent Hall output voltage, are immune to thermal stress, and have precise recoverability after temperature cycling.

Linear device basic specifications (see data sheets for complete specifications) are shown above.

### Calibrated Linear

Allegro offers as an application design aid, a calibrated linear device. This utilizes the newest A3515 or A3516 devices, providing serialized linear devices with a graph of their precise output over a magnetic field of ±400 Gauss (A3515) or ±800 Gauss (A3516). The graph is plotted at three bias voltages 4.5 V, 5 V, and 5.5 V. Designers can use these devices to obtain extremely accurate field-strength measurements. Because the devices are packaged in the popular “U” or “UA” packages, the devices are easily inserted into developmental circuits to provide an easy means of reading actual field strength. This allows precise measurements to be made of magnets and their field strengths at various air gaps. Ultimately, the calibrated linear will provide information that will greatly assist in the final selection of system magnets, air gaps, and the proper digital or linear device for the application.
To use, connect the appropriate terminals to a well-regulated power supply (±0.01 V) and the output to a high-impedance voltmeter. It is also recommended that an external 0.1 μF bypass capacitor be connected (in close proximity to the Hall device) between the supply and ground of the device to reduce both external noise and noise generated by the chopper stabilization technique. An ambient temperature range of +21°C to +25°C should also be maintained. Before use, the device should be powered up and allowed to stabilize.

The calibrated linear device, with its attached calibration curve, affords a convenient method of flux measurement.

Subject the device to the magnetic field in question. Measure the device output voltage and locate that level on the Y axis of the calibration curve. The intersection of that output level with the calibration curve will provide the corresponding flux density on the calibration curve’s X axis.

Alternatively, the sensitivity coefficient (as given on the calibration curve for the device) can be used to calculate flux densities more precisely. First, determine the quiescent output voltage of the device under a zero gauss or “null” field condition. Then, measure the output of the device with the unknown field applied. The magnetic flux density at the chip can then be calculated as:

$$B = \frac{1000 \left( V_{OB} - V_{00} \right)}{k}$$

where

- $B$ = magnetic flux density in gauss
- $V_{OB}$ = output voltage with unknown field applied
- $V_{00}$ = output voltage with zero gauss applied
- $k$ = calibrated device sensitivity in mV/G.

**CURRENT SENSING**

Linear Hall-effect devices are ideal for current sensing. Currents from the low milliampere range into the thousands of amperes can be accurately measured.

The flow of current through a conductor will generate a free-space magnetic field of about 6.9 gauss per ampere. Because the measurement range of a linear Hall-effect device is limited, it is necessary to configure the sensing circuit such that the field strength of the current range to be measured is within the range of the device to be used. In the case of the A3516 this sensing range will be approximately -800 gauss to +800 gauss.

**High-CURRENT Measurement**

For conductors with several hundred to thousands of amperes of current, the linear device can provide a direct usable output, without the use of field-enhancing coils or toroids, by sensing a portion of the total magnetic field generated. Lower currents will need to utilize coils or toroids to increase or concentrate the field to a detectable range. Ideally, the field will be above 100 gauss, placing the device output above signal-to-noise-ratio concerns. The magnetic flux density at the chip can be calculated as:

$$B = \frac{1}{4\pi r} \text{ or } I = 4\pi rB$$

where:

- $B$ = field strength in gauss
- $I$ = current in amperes
- $r$ = distance from wire center to device chip in inches.

Example 1: wire has 0.25" radius, plus 0.1" air gap, 2000 amperes of current flow. $B = \frac{2000}{4.40} = 455$ G.

Example 2: wire has 0.15" radius, plus 0.1" air gap, 300 amperes of current flow. $B = \frac{300}{3.14} = 95$ G.

![Diagram](image)

Note that the Hall element is most sensitive to magnetic fields passing perpendicularly through it. Flux lines at an angle to the device will generate reduced (cosine of the angle) Hall voltages and flux lines at 90° angles will produce a zero gauss indication.

**Using A Coil for Increased Sensitivity**

Flux density can be increased with the use of a coil. Using a total device-to-coil air gap of 0.060" yields an increase in flux density:

$$B = 6.9nI \text{ or } n = \frac{B}{6.9I}$$

where $n =$ number of turns of wire in the coil.
For example, to indicate 400 gauss at 12 amperes:
\[ n = \frac{400}{83} \approx 5 \text{ turns}. \]

**Using A Toroid for Maximum Sensitivity**

Accurate current measurements below about 120 amperes is best accomplished using a gapped toroid with the current-carrying conductor passing through the toroid and the device positioned in the toroid gap. The toroid will concentrate the magnetic field through the sensing element. Magnetic fields below 1 gauss are difficult to measure due to the internal noise associated with the solid-state device and amplifiers. The wide-band output noise of the device is typically 400 mV rms (or an error of about 32 mA).

To measure low currents, the conductor should be passed through the toroid multiple times (n), resulting in
\[ B = 6.9nI \]
where \( n \) = the number of turns.

**LINEAR DEVICE APPLICATIONS USING PERMANENT MAGNETS**

In many applications, the linear device will be used in conjunction with a permanent magnet. Several magnet configurations are shown below. To maximize linearity, a large change in field strength vs. the required displacement is desired. Careful selection of the magnet(s), and the sensing technique, will pay large dividends. In general, high-quality, high field-strength magnets are required for most linear sensing applications. Samarium-cobalt or Alnico 8 magnets are recommended.

**Head-On Sensing (Single Magnet)**

Though straightforward, a head-on approach produces an output that mimics the magnetic field, which produces a nonlinear output vs. air gap. At small air gaps the change in output voltage vs. air gap is large, and for some applications may be considered “linear”. At larger air gaps, the output assumes a pronounced nonlinear characteristic. Linear devices will accurately track positive or negative magnetic fields.

**Features:**
- device output tracks magnetic field and
- simple mechanical configuration.
Slide-By Sensing (Single Magnet)

Slide-by sensing is a non-complex method of obtaining a linear output voltage vs. slide-by movement. Depending upon the location of the device relative to the zero-field center of the magnet, both negative and positive outputs can be produced. As the first graph shows, the center portion of the output is very linear and becomes a good choice for potentiometer, air valve, and throttle-position valve type applications.

Features:
- very linear output vs. position over a small range
- very steep magnetic (output voltage) slopes,
- very high flux density change relative to distance, and
- output is nearly rail-to-rail (ground to VCC).

Push-Pull Approach

The device moves between two magnets. Complementary fields provide a linear, steep-sloped output. The output will range from zero to near plus/minus rail voltage with the polarity dependent on orientation of the magnets.

Features:
- steep magnetic (output voltage) slope,
- output is nearly rail-to-rail (ground to VCC) with polarity dependent upon magnet orientation), and
- insensitive to precise positioning.
Compound Magnets

Compound magnets can be used to produce specialized outputs, including sine-wave-type outputs.

Magnetically Biased Linear Sensing

Linear devices can be used to detect the presence or absence of a ferrous metal target. This requires bonding a biasing magnet onto the device*. This technology can also be used for notch or gear-tooth sensing although specialized gear-tooth device designs may be better suited for these applications.

OPTIMIZED LINEAR OUTPUTS

Several common circuits are used, in conjunction with linear devices, to optimize their outputs for specialized applications.

A/D Converter Interface

Linear devices can provide input for analog-to-digital converters. Ratiometric linear devices can be powered from the A/D reference voltage source, allowing the device to track changes in the A/D LSB (least significant bit) value. As the reference voltage varies, the LSB will vary proportionally.

Look-Up Tables

When digital data is provided to a microprocessor, the device’s output can be referenced to a lookup table, correcting for any non-linearity.

Comparators

Comparators can be utilized to provide a set point or trip point and thereby convert the linear device into an adjustable digital switch although chopper-stabilized Hall-effect switches may be better suited for these applications.

Operational Amplifiers

Operational amplifiers can be used to boost the output of the device to higher output levels and to provide adjustable offsets.

*Especially with older device designs, special precautions regarding soldering, gluing, potting, and encapsulating of Hall-effect devices may apply. Application note 27703.1 is available on request.
MAGNETS

Many linear-sensing applications will need high-quality magnets to optimize air gaps and provide stable fields over wide temperature ranges. The table below is a guide to basic magnet characteristics. Detailed information on particular magnet types is available from the manufacturers (see supplement).

Choosing a Magnet

A magnet must have sufficient flux density to generate the desired linear device output, at the working air gap required by the application. Other considerations are the temperature coefficient of the magnet and its coercive force. Coercive force is basically the measure of a magnet’s ability to retain its magnetic force when subjected to a strong demagnetizing field. The larger a magnet’s coercive force, the less susceptible it is to being demagnetized.

Temperature Coefficient of Magnets

Temperature coefficient is the rate of change of the magnet’s field strength over temperature, measured in gauss per degree Celsius. This is an important consideration when selecting a magnet, particularly for linear applications.

Properties of Magnetic Materials

| Material          | Maximum energy product (gauss-oersted) | Residual induction (gauss) | Coercive force (oersteds) | Temperature coefficient | Cost   | Comments                                           |
|-------------------|-----------------------------------------|---------------------------|---------------------------|-------------------------|--------|**************************************************|
| R.E. cobalt       | 16 x 10^6                               | 8.1 x 10^3                | 7.9 x 10^3                | -0.05%/°C               |       | Strongest, smallest, resists demagnetizing best |
| Alnico 1, 2, 3, 4 | 1.3 - 1.7 x 10^6                        | 5.5 - 7.5 x 10^3          | 0.42 - 0.72 x 10^3        | -0.02%/°C to -0.03%/°C  | Medium | Non-oriented                                      |
| Alnico 5, 6, 5-7  | 4.0 - 7.5 x 10^6                        | 10.5 - 13.5 x 10^3        | 0.64 - 0.78 x 10^3        | -0.02%/°C to -0.03%/°C  | Medium-high | Oriented                                           |
| Alnico 8          | 5.0 - 6.0 x 10^6                        | 7.9 - 12 x 10^3           | 1.5 - 1.9 x 10^3          | -0.01%/°C to +0.01%/°C  | Medium-high | Oriented, high coercive force, best temperature coefficient |
| Alnico 9          | 10 x 10^6                               | 10.5 x 10^3               | 1.6 x 10^3                | -0.02%/°C               | High   | Oriented, highest energy product                  |
| Ceramic 1         | 1.0 x 10^6                              | 2.2 x 10^3                | 1.8 x 10^3                | -0.2%/°C                | Low    | Nonoriented, high coercive force, hard, brittle, non-conductor |
| Ceramic 2, 3, 4, 6| 1.8 - 2.6 x 10^6                        | 2.9 - 3.3 x 10^3          | 2.3 - 2.8 x 10^3          | -0.2%/°C                | Low-medium | Partially oriented, very high coercive force, hard, brittle, non-conductor |
| Ceramic 5, 7, 8   | 2.8 - 3.5 x 10^6                        | 3.5 - 3.8 x 10^3          | 2.5 - 3.3 x 10^3          | -0.2%/°C                | Medium | Fully oriented, very high coercive force, hard, brittle, non-conductor |
| Cunife            | 1.4 x 10^6                              | 5.5 x 10^3                | 0.53 x 10^3               | —                      | Medium | Ductile, can cold form and machine                |
| Fe-Cr             | 5.25 x 10^6                             | 13.5 x 10^3               | 0.60 x 10^3               | —                      | Medium-high | Can machine prior to final aging treatment |
| Plastic           | 0.2 - 1.2 x 10^3                        | 1.4 - 3 x 10^3            | 0.45 - 1.4 x 10^3         | -0.2%/°C                | Lowest | Can be molded, stamped, machined                 |
| Rubber            | 0.35 - 1.1 x 10^6                       | 1.3 - 2.3 x 10^3          | 1 - 1.8 x 10^3            | -0.2%/°C                | Lowest | Flexible                                          |
| Neodymium         | 7 - 15 x 10^6                           | 6.4 - 11.75 x 10^3        | 5.3 - 6.5 x 10^3          | -0.157%/°C to -0.192%/°C| Medium-high | Non-oriented                                     |
Magnetic Materials

**Alnico** is a class of alloys containing aluminum, nickel, cobalt, iron, and additives that can be varied to give a wide range of properties. These magnets are strong, and have low temperature coefficients. Alnico magnets are less expensive than rare-earth cobalt magnets but more expensive than most other materials. Alnico magnets can be cast, or sintered by pressing metal powders in a die and heat treating. Sintered Alnico is well suited to mass production of small, intricately shaped magnets. It has more uniform flux density, and is mechanically superior to most other magnetic materials. Cast Alnico magnets are generally somewhat stronger than non-oriented or isotropic Alnico alloys (1,2,3,4) and are less expensive and magnetically weaker than the oriented alloys (5,6,5-7,8,9). Alnico is too hard and brittle to be shaped except by grinding.

**Ceramic** magnets contain barium or strontium ferrite (or another element from that group) in a matrix of ceramic material that is compacted and sintered. Ceramics are poor conductors of heat and electricity and are chemically inert. As with Alnico, ceramic magnets can be fabricated with an oriented structure for additional magnetic strength. Ceramic magnets are less expensive than Alnico, and have a lower maximum energy product.

**Cunife** magnets are made from a ductile copper-base alloy with nickel and iron. They can be stamped, swagged, drawn, or rolled into final shape.

**Iron-Chromium (Fe-Cr)** magnets have magnetic properties similar to Alnico 5, but are soft enough to be machined before final heat treatment hardens them.

**Neodymium (Ne-Fe-B)** magnets compare in strength with rare-earth magnets, are less expensive, but have poor temperature coefficients. Neodymium magnets are produced by either a powered-metal technique called “orient-press-sinter” or by casting. Oxidation problems can be overcome through the use of modern coatings.

**Plastic or Rubber** magnets consist of barium or strontium ferrite in a plastic or rubber matrix. These are the least expensive magnets but have the lowest maximum energy product. Plastic or rubber magnets can be formed by stamping, molding, or machining.

**Rare-Earth Cobalt** magnets are alloys of rare-earth metals (such as samarium) with cobalt. These magnets are the best in all categories but are also the most expensive. The material is too hard for machining and must be ground if shaping is necessary.